Two Stage Etching of Silicon Nitride to Form a Nitride Spacer Barbara A. Haselden; John Lee M—12473 US

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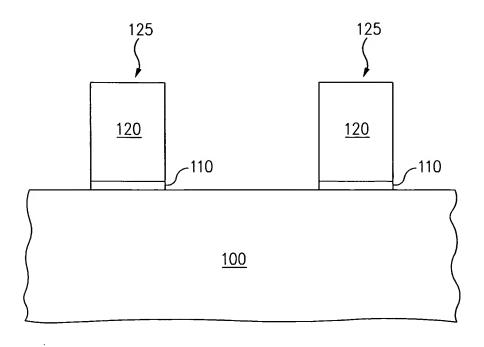


FIG. 1

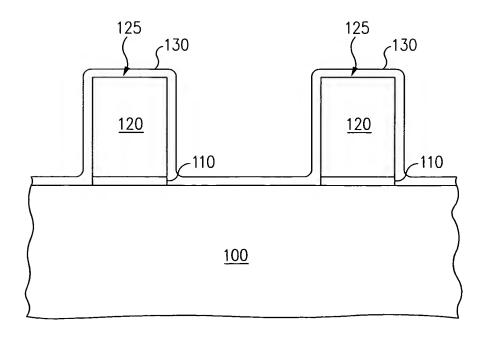


FIG. 2

Two Stage Etching of Silicon Nitride to Form a Nitride Spacer.

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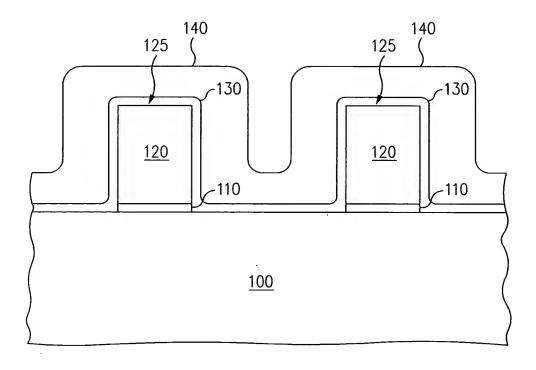


FIG. 3

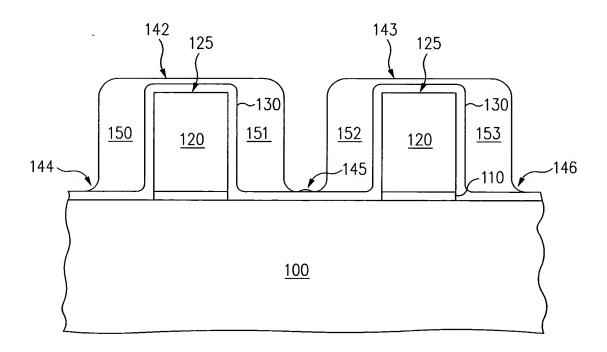


FIG. 4

## Two Stage Etching of Silicon Nitride to Form a Nitride Spacer Barbara A. Haselden; John Lee M-12473 US

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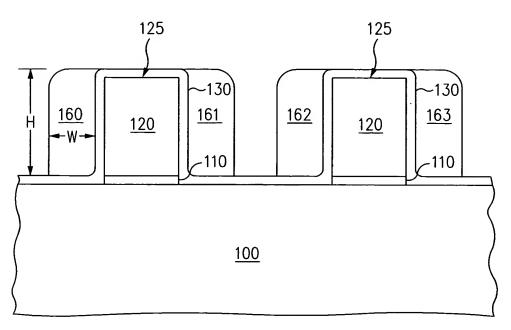


FIG. 5

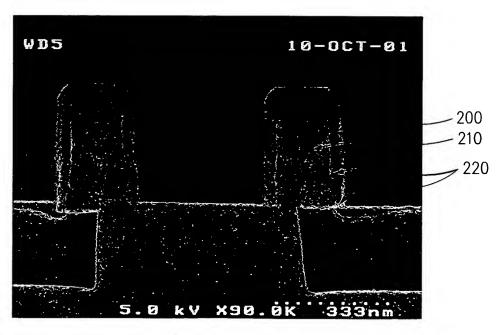


FIG. 6
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